

dRICH photosensors and electronics

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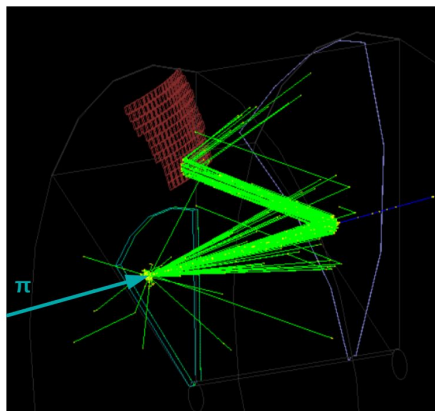
INFN Bologna

on behalf of the dRICH Collaboration

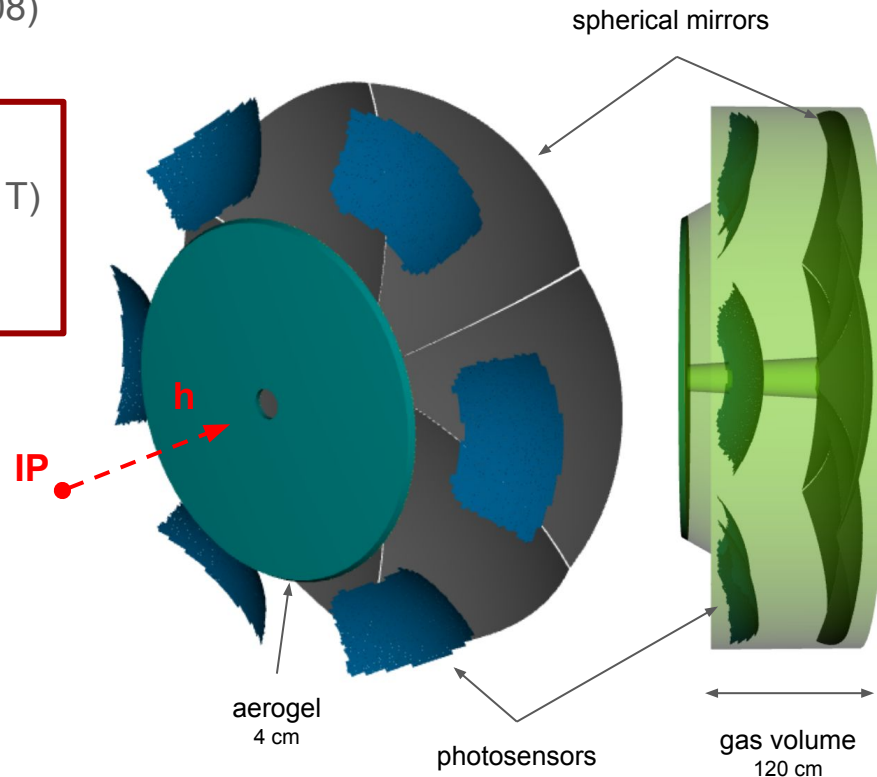
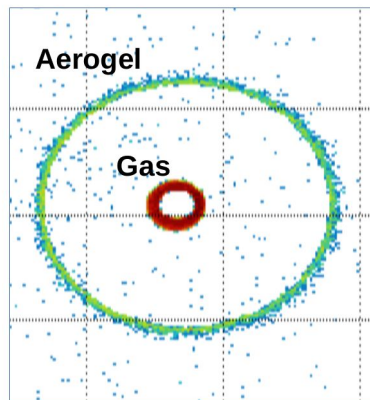
The dual-radiator (dRICH) for forward PID at EIC

compact and cost-effective solution for broad momentum coverage at forward rapidity

- **radiators:** aerogel ($n \sim 1.02$) and C_2F_6 ($n \sim 1.0008$)
- **mirrors:** large outward-reflecting, 6 open sectors
- **sensors:** $3 \times 3 \text{ mm}^2$ pixel, 0.5 m^2 / sector
 - single-photon detection inside high B field ($\sim 1 \text{ T}$)
 - outside of acceptance, reduced constraints
 - best candidate: **SiPM option**



example event (accumulated hits)

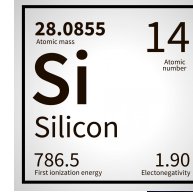


SiPM option and requirements for RICH optical readout



● pros

- cheap
- high photon efficiency requirement ☐
- excellent time resolution requirement ☐
- insensitive to magnetic field requirement ☐

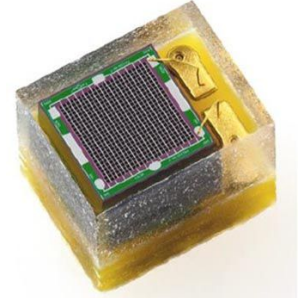


● cons

large dark count rates
not radiation tolerant

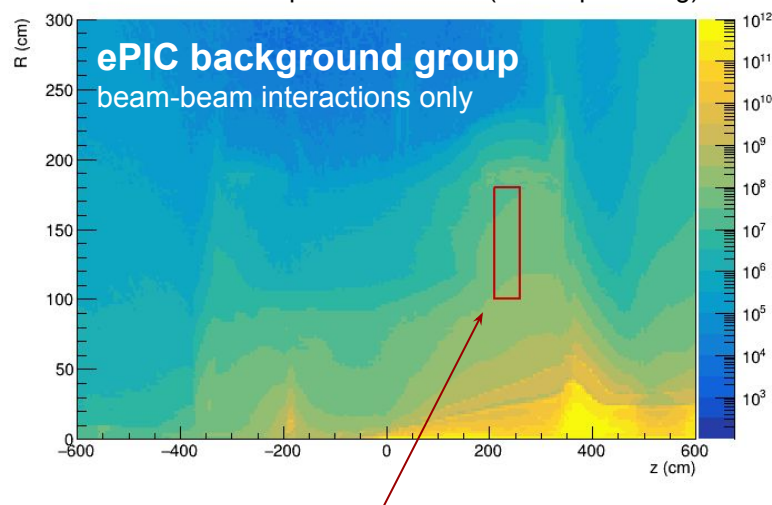
technical solutions and mitigation strategies

- cooling
- timing
- annealing



Neutron fluxes at the dRICH photosensor surface

1-MeV neutron equivalent fluence (1 fb^{-1} ep running)



location of dRICH photosensors

mean fluence: $3.9 \cdot 10^5 \text{ neq} / \text{cm}^2 / \text{fb}^{-1}$

max fluence: $9.2 \cdot 10^5 \text{ neq} / \text{cm}^2 / \text{fb}^{-1}$

- radiation level is moderate

assume fluence: $\sim 10^7 \text{ neq} / \text{cm}^2 / \text{fb}^{-1}$

conservatively assume max fluence and 10x safety factor

Most of the key Physics goals defined by the NAS require an integrated luminosity of 10 fb^{-1} per center of mass energy and polarization setting

The nucleon imaging programme is more luminosity hungry and **requires 100 fb^{-1} per center of mass energy and polarization setting**

in 10-12 years the EIC will accumulate 1000 fb^{-1} integrated \mathcal{L} corresponding to an integrated fluence of $\sim 10^{10} \text{ n}_{\text{eq}}/\text{cm}^2$

study the SiPM usability for single-photon Cherenkov imaging applications in moderate radiation environment

→ radiation damage studied in steps of radiation load

$10^9 \text{ 1-MeV } n_{\text{eq}}/\text{cm}^2$

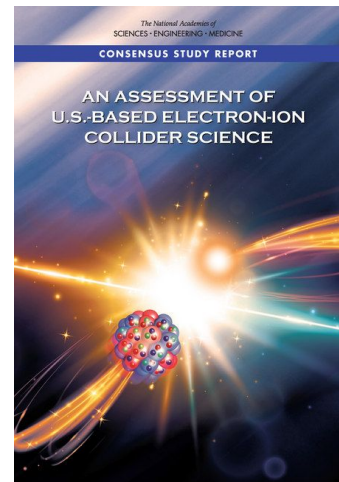
most of the key physics topics

$10^{10} \text{ 1-MeV } n_{\text{eq}}/\text{cm}^2$

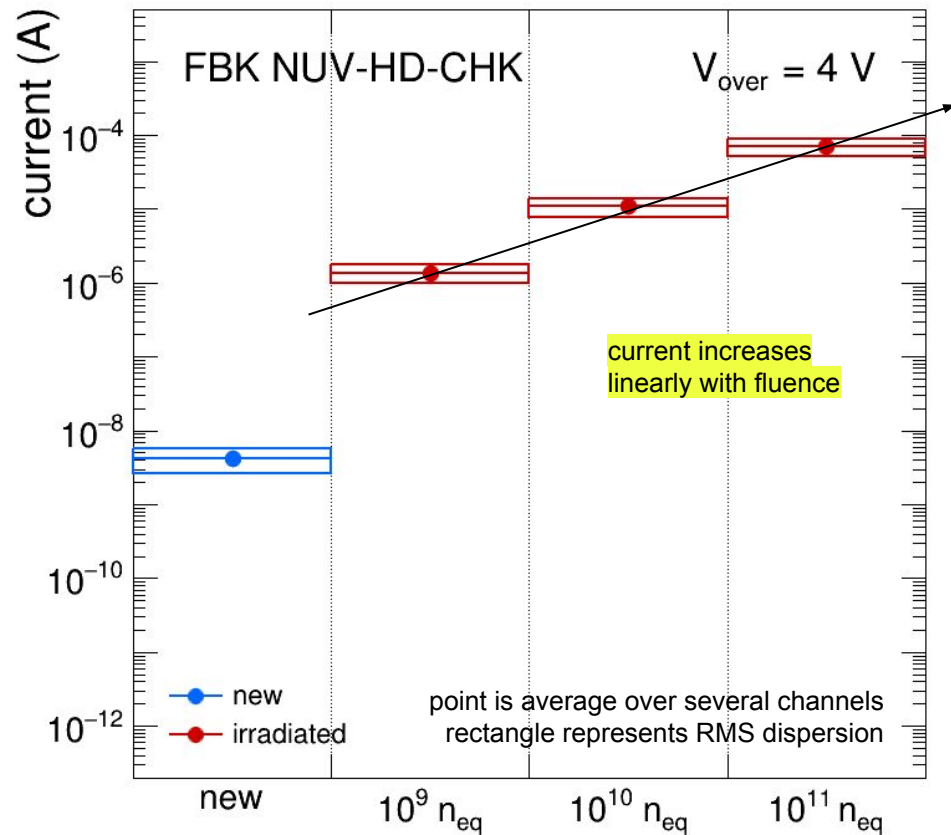
should cover most demanding measurements

$10^{11} \text{ 1-MeV } n_{\text{eq}}/\text{cm}^2$

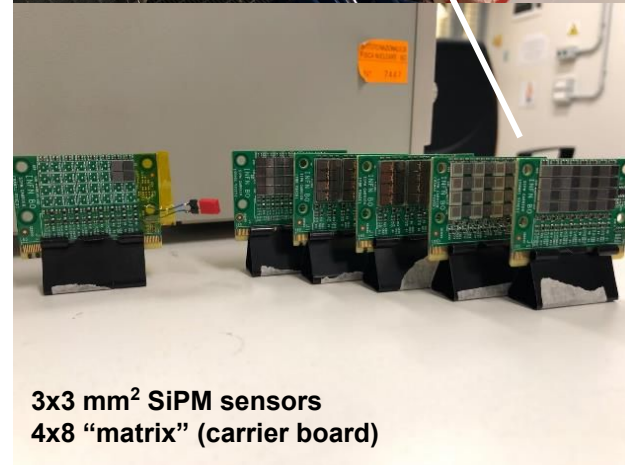
might never be reached



Studies of radiation damage on SiPM



all results are reported at $T = -30 \text{ C}$



Commercial SiPM sensors and FBK prototypes

| board | sensor | uCell (μm) | V _{bd} (V) | PDE (%) | DCR (kHz/mm ²) | window | notes |
|-------|----------------|------------|---------------------|---------|----------------------------|----------|--|
| HAMA1 | S13360 3050VS | 50 | 53 | 40 | 55 | silicone | legacy model Calvi et. al |
| | S13360 3025VS | 25 | 53 | 25 | 44 | silicone | legacy model smaller SPAD |
| HAMA2 | S14160 3050HS | 50 | 38 | 50 | | silicone | newer model lower V _{bd} |
| | S14160 3015PS | 15 | 38 | 32 | 78 | silicone | smaller SPADs radiation hardness |
| SENSL | MICROFJ 30035 | 35 | 24.5 | 38 | 50 | glass | different producer and lower V _{bd} |
| | MICROFJ 30020 | 20 | 24.5 | 30 | 50 | glass | the smaller SPAD version |
| BCOM | AFBR S4N33C013 | 30 | 27 | 43 | 111 | glass | commercially available FBK-NUVHD |

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NUV-HD-CHK

NUV-HD big cells

Technology similar to NUV-HD-Cryo
Optimized for single photon timing

- Cell pitch 40 μm
- High PDE > 55%
- Primary DCR @ +24°C ~ 50 kHz/mm²
- Correlated noise 35% @ 6 V

NUV-HD-RH

NUV-HD-RH

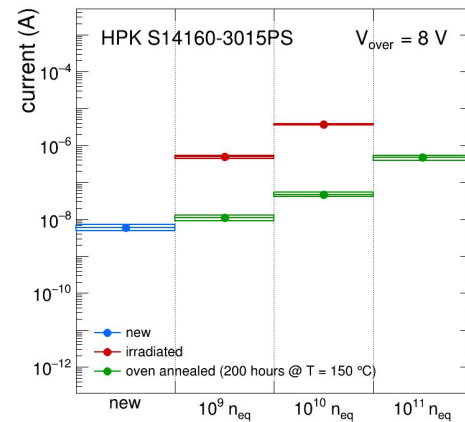
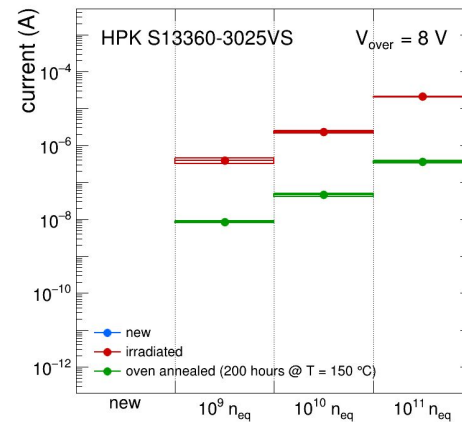
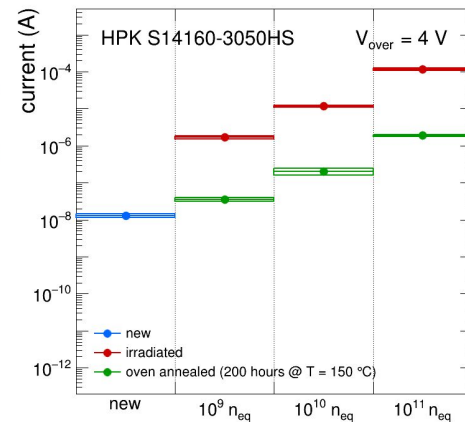
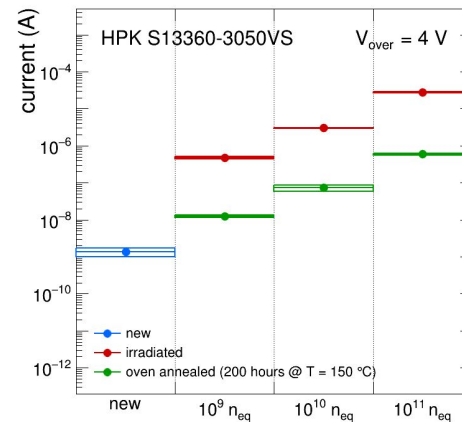
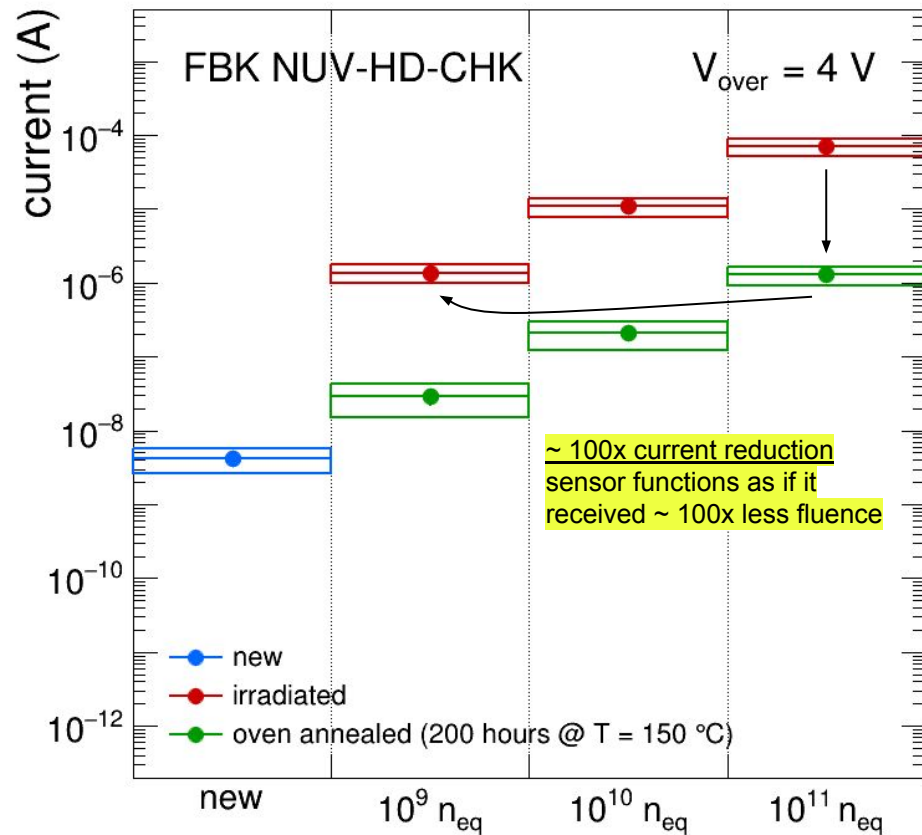
Technology under development
optimized for radiation hardness in
HEP experiments

- Cell pitch 15 μm with high fill factor
- Fast recovery time – reduced cell occupancy
Tau recharge < 15 ns
- Primary DCR @ +24°C ~ 40 kHz/mm²
- Correlated noise 10% @ 6 V

multiple producers: different technologies, SPAD dimensions, V_{bd}, electric field ...

High-temperature annealing recovery

oven annealing
~ 1 week at 150 C



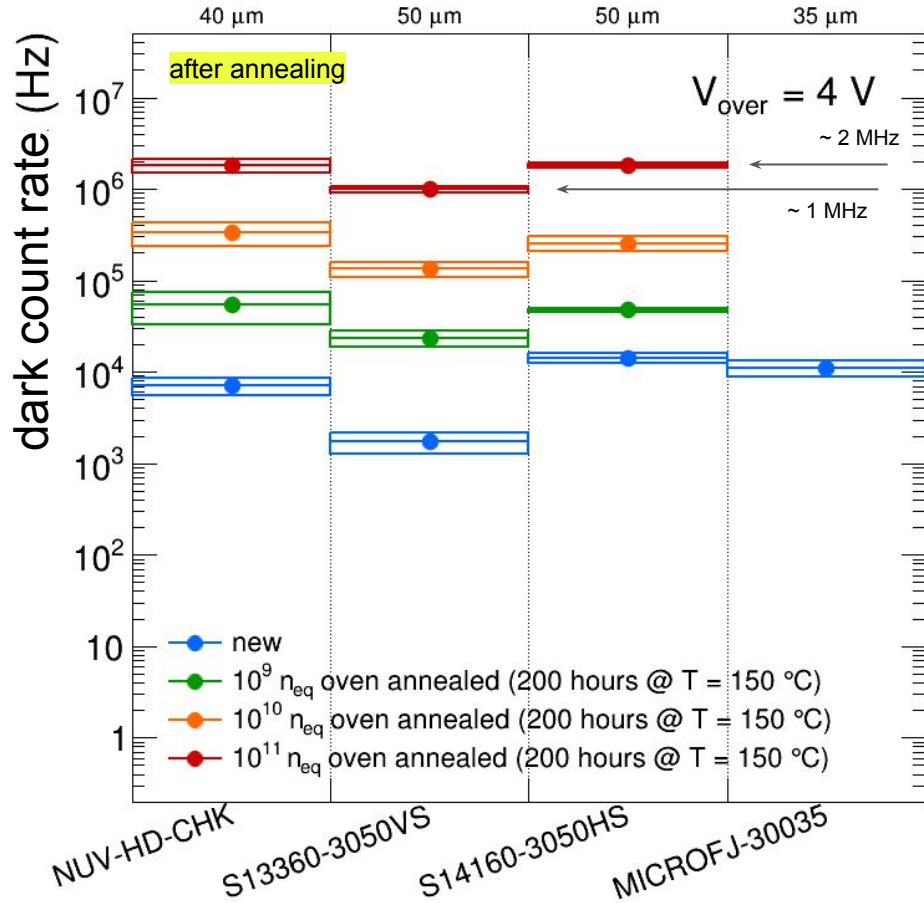
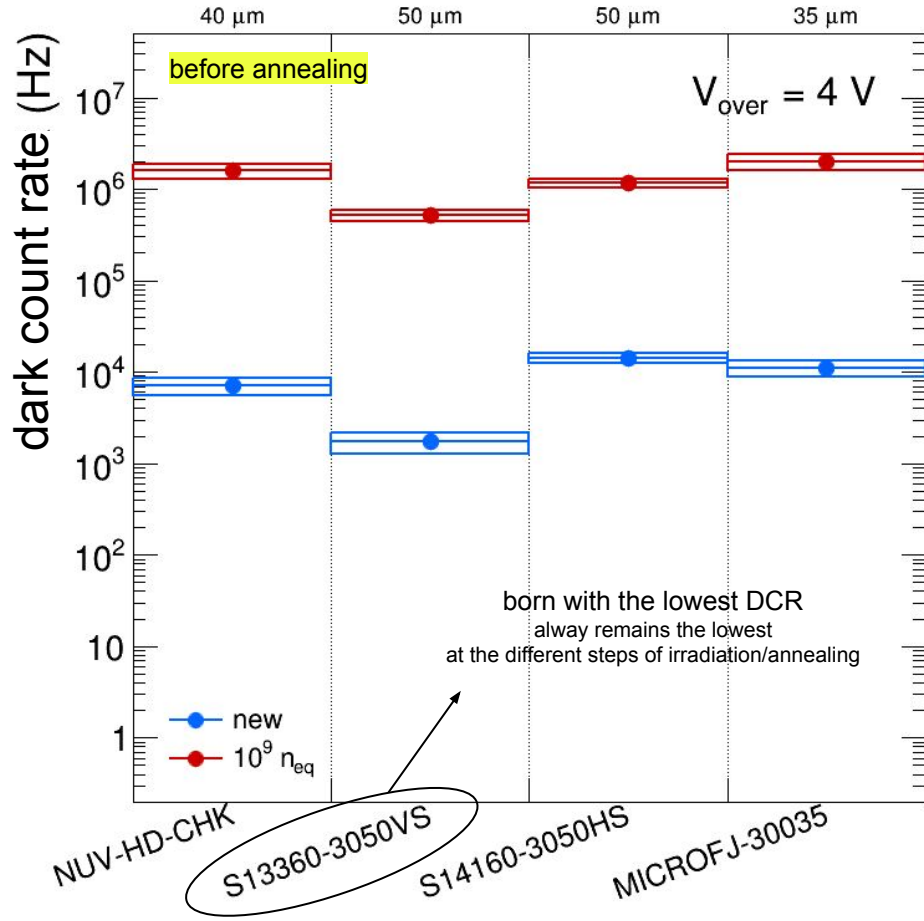
similar observation with various types of Hamamatsu sensors

Comparison between different sensors

comparison at same Vover not totally fair

important to consider PDE (and SPTR) \rightarrow SNR \sim PDE / DCR

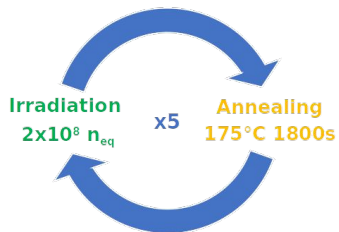
unlikely 2x larger DCR is matched by 2x larger PDE



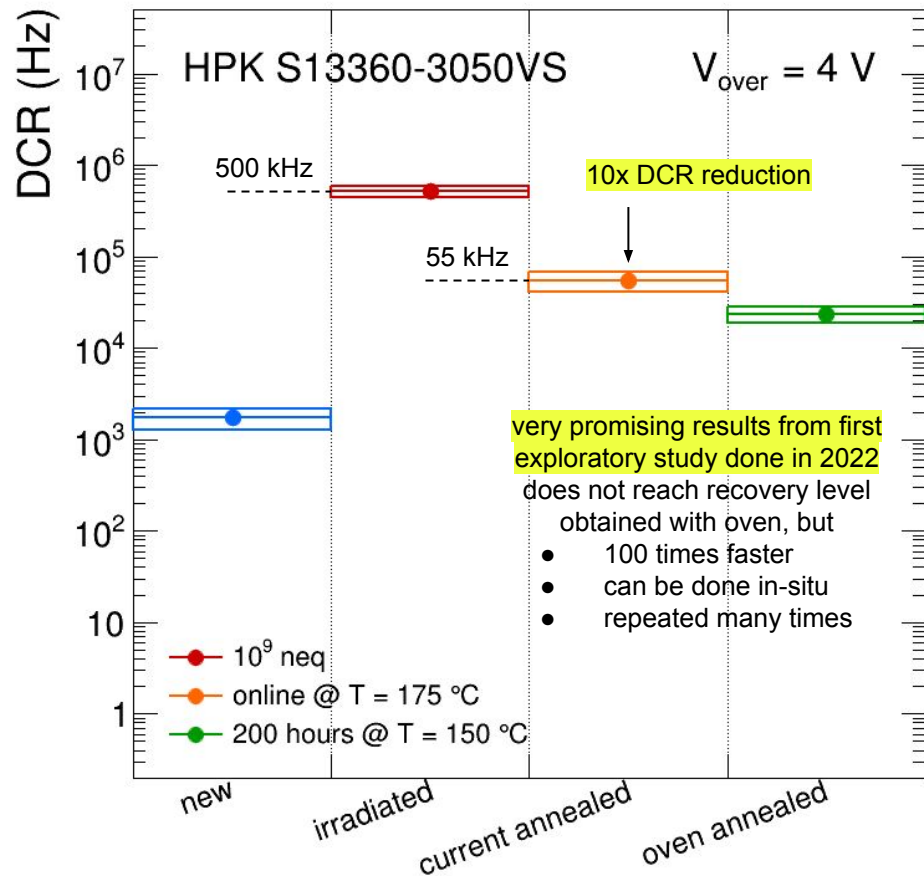
“Online” self-induced annealing



irradiation interleaved
with annealing cycle
realistic experimental case



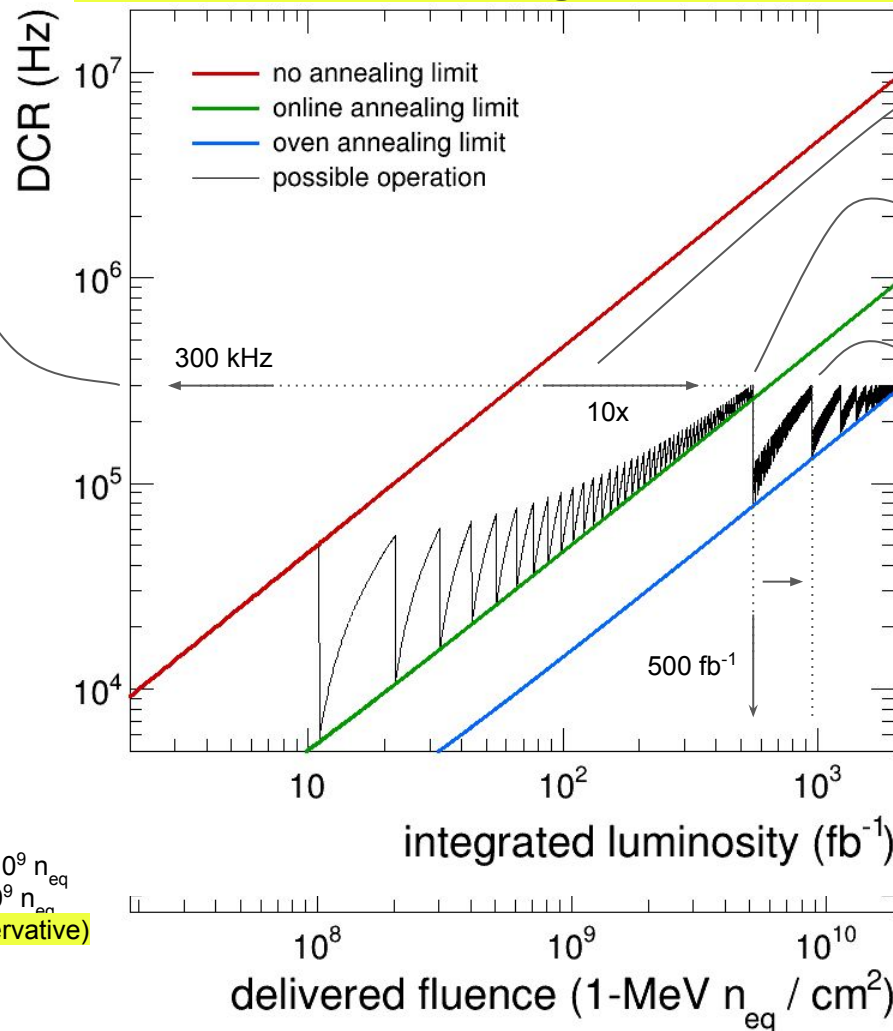
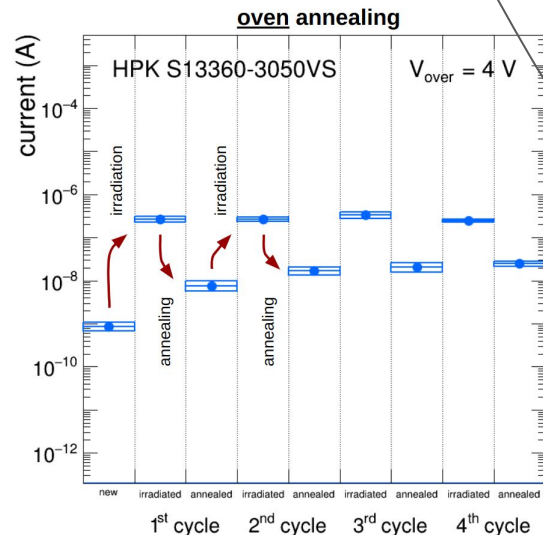
studies for “in-situ” SiPM recovery
multiple cycles: 30 minutes at 175 C
~ 1 W power/sensor delivered with forward bias voltage



Ageing model

Hamamatsu S131360-3050 @ $V_{\text{over}} = 4 \text{ V}$, $T = -30 \text{ C}$

max acceptable DCR for
Physics performance
~ 10 noise hits / sector within 500 ps



online annealing
extends SiPM
lifetime by ~ 10x

more aggressive
annealing needed here
might need to unmount SiPM (oven)

up to 1000 fb⁻¹ with only
one oven annealing cycle
optimisation of online annealing
protocol could reach beyond that

model input from R&D measurements

- DCR increase: 500 kHz/10⁹ n_{eq}
- residual DCR (online annealing): 50 kHz/10⁹ n_{eq}
- residual DCR (oven annealing): 15 kHz/10⁹ n_{eq}

1-MeV n_{eq} fluence from background group (conservative)

- 9 10⁶ n_{eq} / fb⁻¹
- includes 10x safety factor

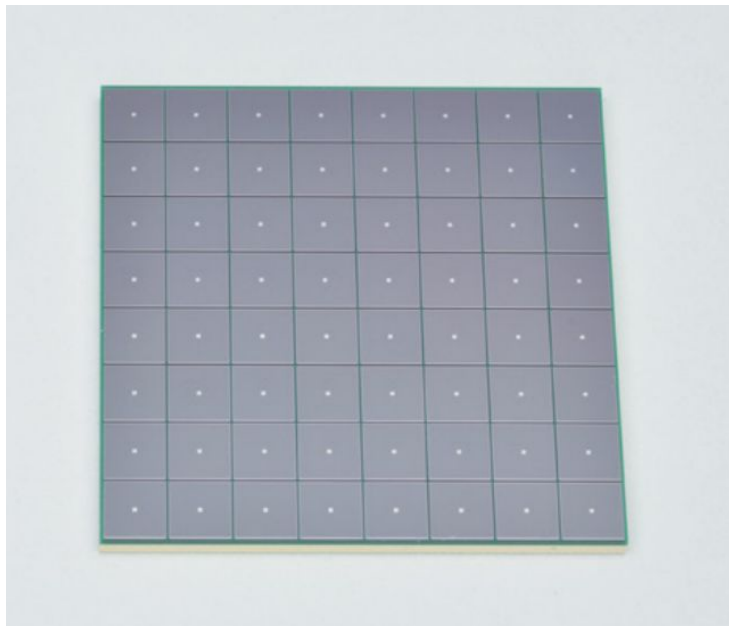
these predictions are according to
present knowledge / tested solutions
**there are more handles to
further mitigate DCR**

lower V_{over} , 3V
lower T operation -40 C or below

SiPM technical specs

baseline sensor device

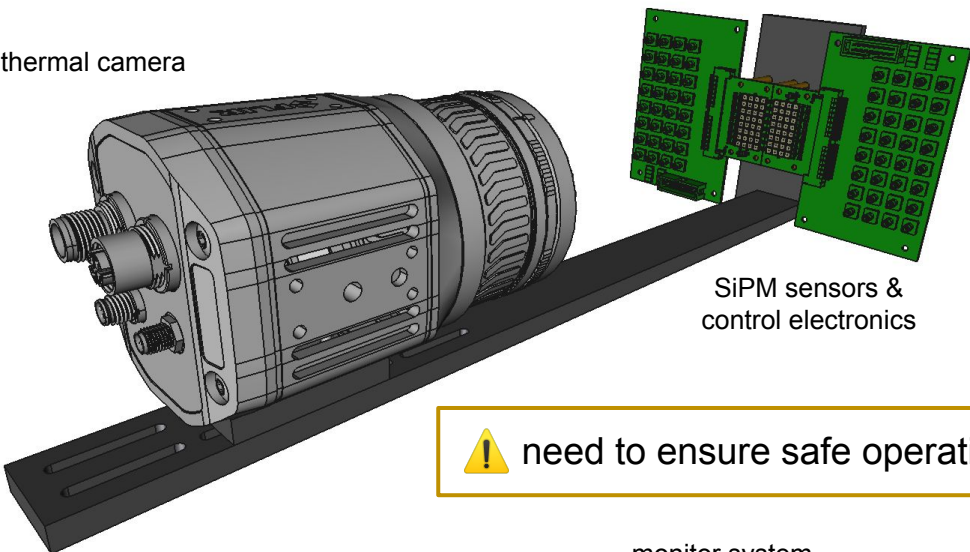
64 (8x8) channel SiPM array
3x3 mm² / channel



| Parameters (at Vop, T = 25 C, unless specified) | Symbol | Value | Notes |
|--|--------|---------------------------------|------------------------------|
| Package type | | SiPM array | |
| Mounting technology | | surface mount | wire bonding also acceptable |
| Number of channels | | 64 (8 x 8) | 8 (2 x 4) also acceptable |
| Effective photosensitive area / channel | | 3 x 3 mm ² | |
| Package dimension | | < 26 x 26 mm ² | |
| Fraction of active area in package | | > 85 % | |
| Microcell pitch | | 50 or 75 um | |
| Number of microcells | Nspad | > 1500 | |
| Protective window material | | Silicone resin | radiation / heat resistant |
| Protective window refractive index | | 1.55 - 1.57 | |
| Spectral response range | | 300 to 900 nm | |
| Peak sensitivity wavelength | Lambda | 400 - 450 nm | |
| Photon detection efficiency at Lambda | | > 40% | |
| Breakdown voltage | Vbreak | < 60 V | |
| Operating overvoltage | Vover | < 5 V | |
| Operating voltage | Vop | Vbd + Vover | |
| Max Vop variation between channels | | < 100 mV | at T = -30 C |
| Dark count rate | DCR | < 500 kHz | |
| DCR at T = -30 C | | < 5 kHz | at T = -30 C |
| DCR increase with radiation damage | | < 500 kHz / 10 ⁹ neq | at T = -30 C |
| Residual DCR after annealing | | < 50 kHz / 10 ⁹ neq | at T = -30 C |
| Terminal capacitance | | < 500 pF | |
| Gain | | > 1.5 10 ⁶ | |
| Recharge time constant | Tau | < 100 ns | |
| Crosstalk | CT | < 5% | |
| Afterpulsing | AP | < 5% | |
| Operating temperature range | | -40 C to 25 C | |
| Single photon time resolution | SPTR | < 200 ps FWHM | |

Automated multiple SiPM online self-annealing

thermal camera



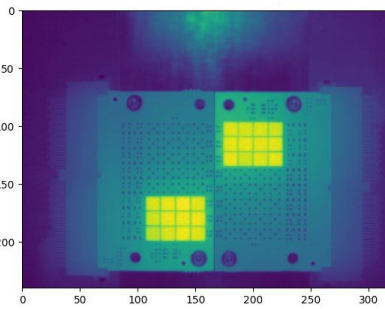
SiPM sensors & control electronics

demonstrator system for online temperature monitor and control of each individual SiPM

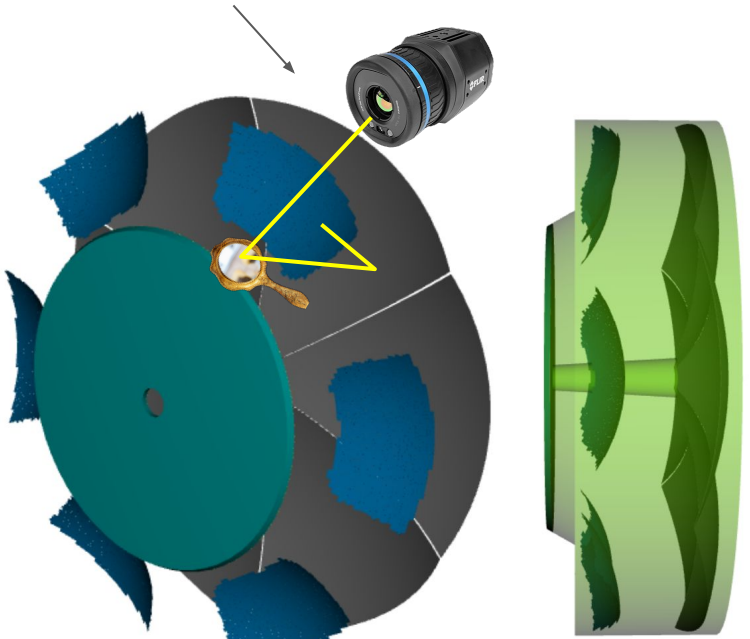
technical feasibility and implementation in the experimental environment to be studied in details

! need to ensure safe operation

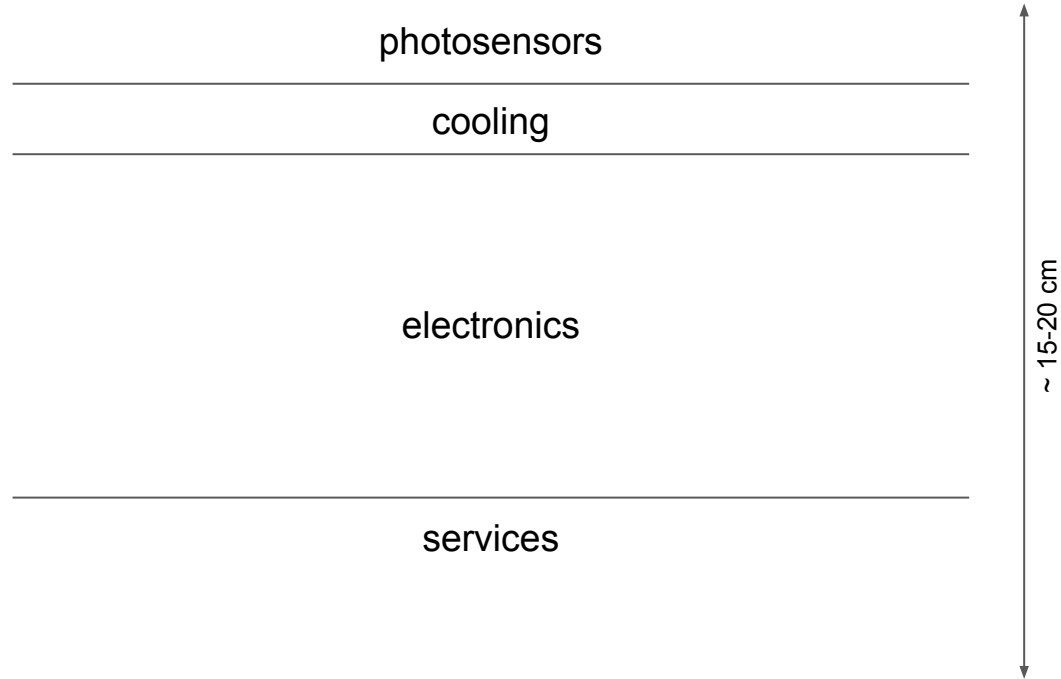
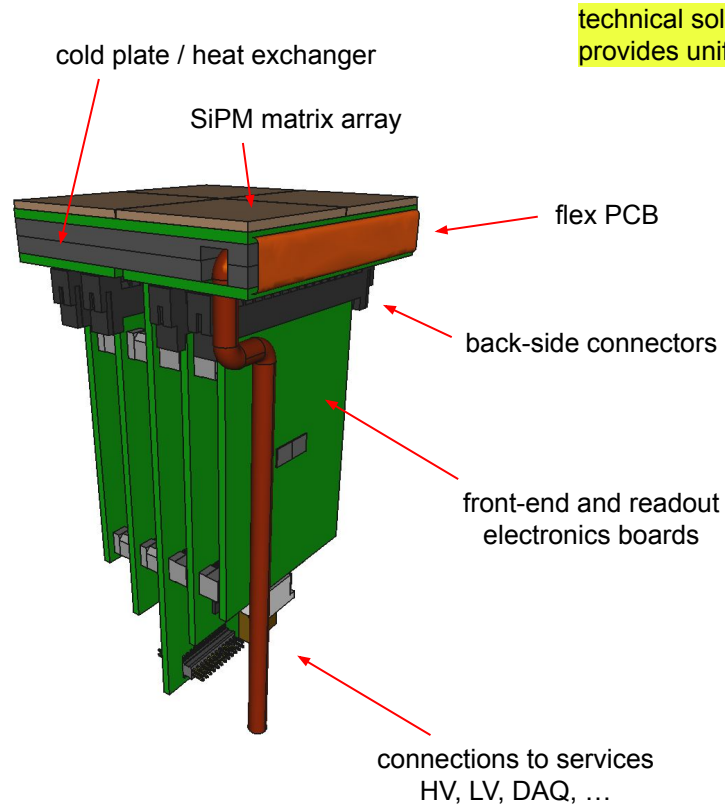
thermal image



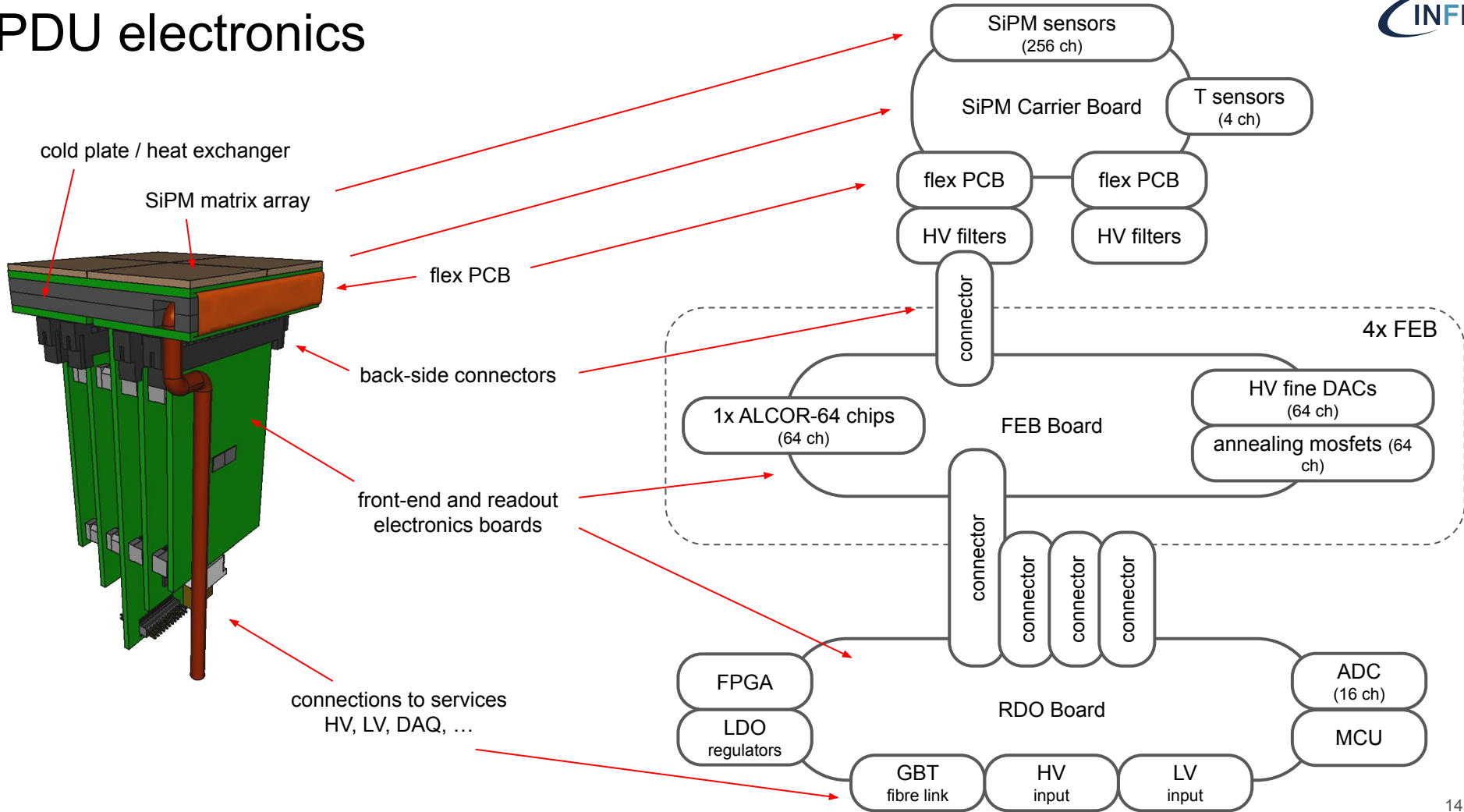
monitor system



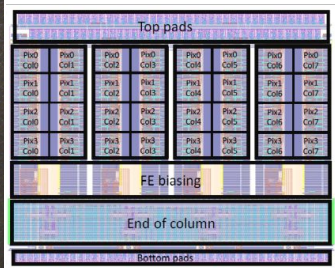
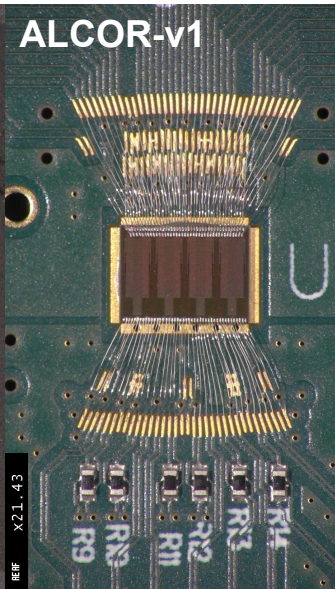
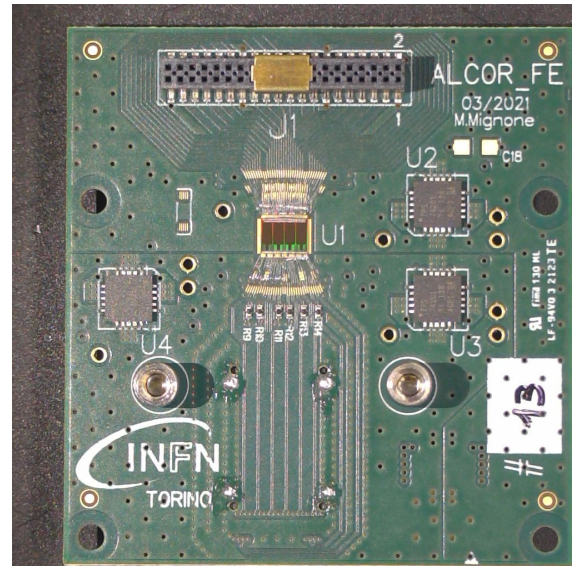
SiPM photodetector unit – PDU



PDU electronics



ALCOR ASIC: integrated front-end and TDC

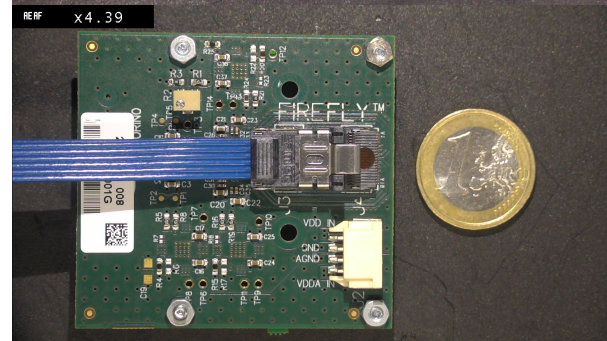


developed by INFN-TO

64-pixel matrix mixed-signal ASIC

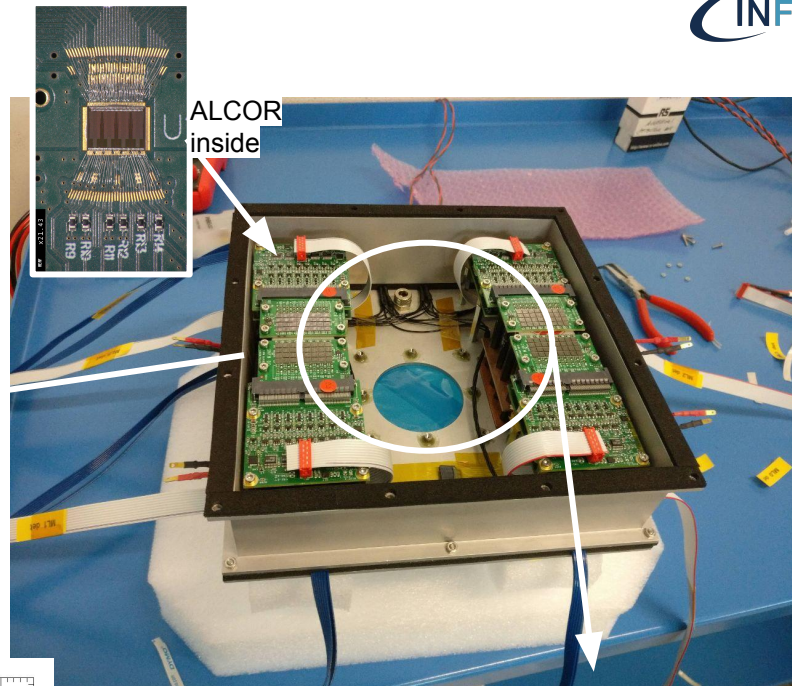
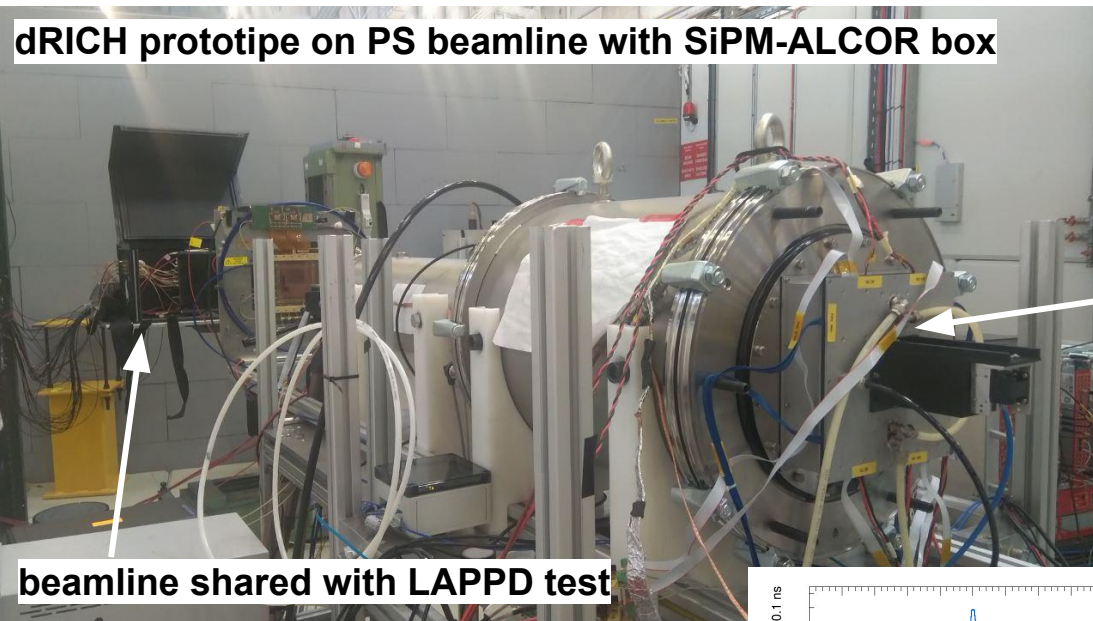
current versions (v1,v2) have 32 channels, wirebonded
final version will have 64 channels, BGA package, 394.08 MHz clock

- **the chip performs**
 - signal amplification
 - conditioning and event digitisation
- **each pixel features**
 - 2 leading-edge discriminators
 - 4 TDCs based on analogue interpolation
 - 20 or 40 ps LSB (@ 394 MHz)
 - digital shutter to enable TDC digitisation
 - suppress out-of-gate DCR hits
 - 1-2 ns timing window
 - programmable delay, sub ns accuracy
- **single-photon time-tagging mode**
 - continuous readout
 - also with Time-Over-Threshold
- **fully digital output**
 - 8 LVDS TX data links

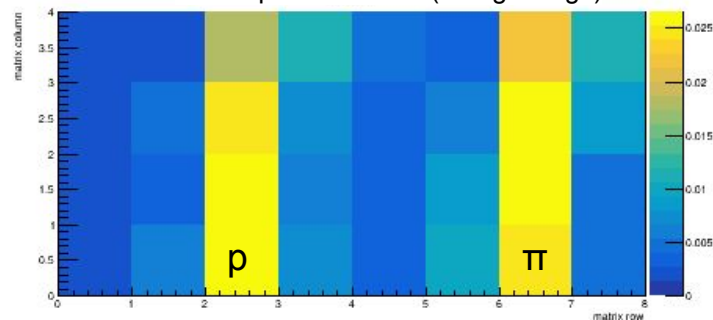
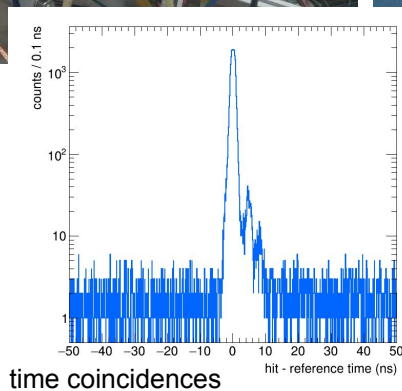


2022 test beam at CERN-PS

dRICH prototype on PS beamline with SiPM-ALCOR box

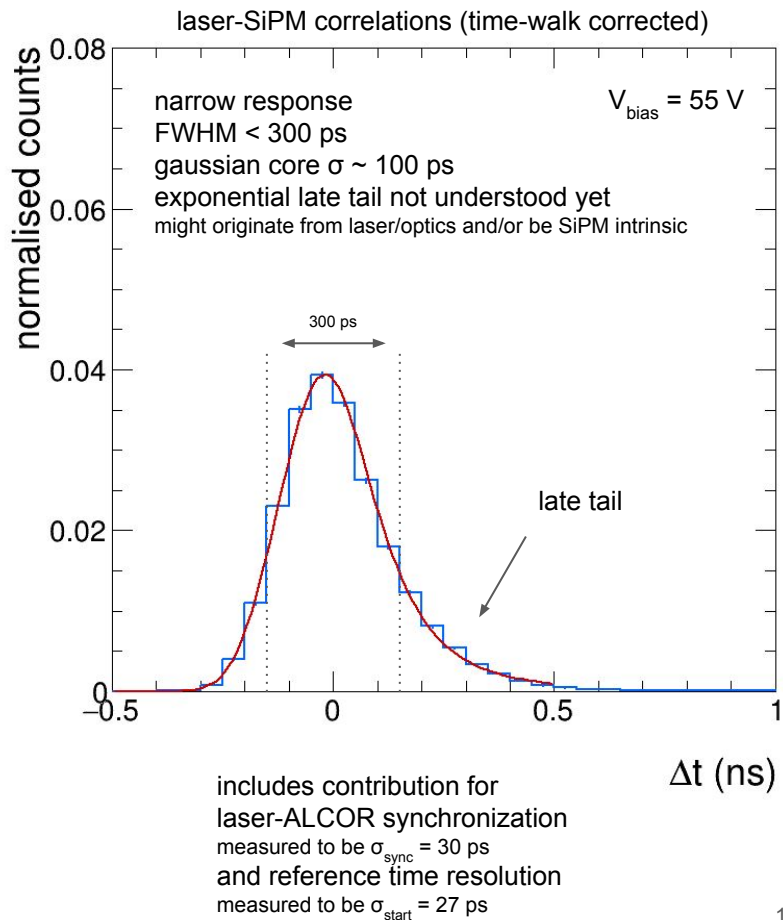
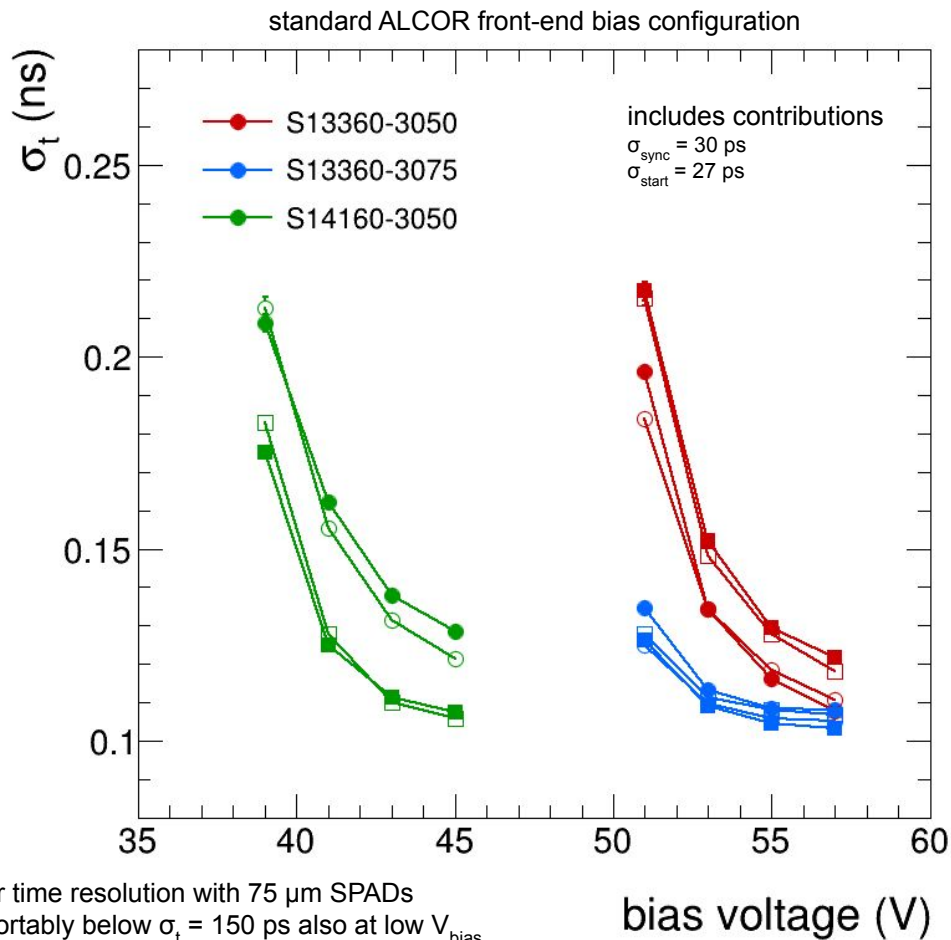


8 GeV positive beam (aerogel rings)



successful operation of SiPM
irradiated (with protons up to 10^{10})
 and annealed (in oven at 150 C)

Laser timing measurements with ALCOR



Current & future plans: sensor optimisation and risk mitigation

- **characterisation measurements**

- measurements of time resolution after irradiation and annealing
- define SiPM performance and comparisons based on SNR (DCR, PDE, SPTR)
- full evaluation of 75 μm SPAD sensors (ie. Hamamatsu S13360-3075)
 - PDE is larger than 50 μm , SPTR is better, DCR is similar
- full evaluation of new Hamamatsu SiPM prototypes (based on S13360 technology)
 - improved NUV sensitivity, improved signal shape and recharge time
 - already received 50 μm and 75 μm samples

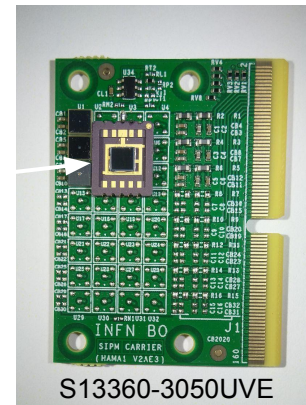
- **operation and annealing**

- test low-temperature (down to $T = -40\text{ C}$) operation with fluid-based chiller
 - evaluate possibility of using the system in heating mode for annealing
- study the details of “in-situ” online self-induced annealing
 - forward (safer, but larger currents) vs. reverse (less safe, lower currents) bias operation
 - recovery vs. annealing temperature and time
 - refine technical solutions (and electronics) for monitor and control in the experiment

- **engineering run with FBK**

- optimisations for the EIC of the already-mature NUV-HD technology (lower field / shaping to improve DCR)
- development of single-die multi-channel SiPM sensor (achieve high fraction of active area with a low-cost process)

This list is not exhaustive and only contains the most important items and steps towards the TDR



Summary

- **dRICH SiPM option fulfills dRICH requirements**
 - magnetic field limitations
 - excellent timing and efficiency
- **technical solutions to mitigate radiation damage**
 - low temperature operation
 - online “in-situ” self-annealing
 - extend lifetime of good detector performance for Physics
 - present solutions can be optimised/improved to extend it further
- **SiPM readout with full electronics chain**
 - based on ALCOR ASIC
 - successful beam test at CERN-PS in 2022
 - overall 1-pe time resolution approaching 100 ps
- **clear path for optimisation towards TDR**
 - good feeling on 75 μm SPAD sensors
 - new Hamamatsu prototypes and FBK developments
 - development of RDO
 - ALCOR-v3, optimisation and final packaging